

ADM/REG/



Docket No.: 0020-5179P  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Zhiqiang WEI et al.

Application No.: 10/665,496

Confirmation No.: 6865

Filed: September 22, 2003

Art Unit: 1762

For: A THIN FILM METAL OXIDE AND A  
METHOD FOR PREPARING IT

Examiner: F. J. Parker

**AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated May 22, 2006, please amend the above-identified U.S. patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 7 of this paper.